



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Won-Sang SONG et al.

Art Unit: 2826

Serial No.: 10/823,544

Examiner: Tuan N. Quach

*Division of Serial No. 09/949,853
filed on September 12, 2001*

Filed: April 14, 2004

Confirmation No.: 4407

For: SEMICONDUCTOR DEVICE HAVING A METAL
SILICIDE LAYER AND METHOD FOR
MANUFACTURING THE SAME

Attorney Docket No.: 253/007 DIV

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop: Amendment
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office action mailed on October 10, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.